

Spatial control of surface plasmon polariton excitation at planar metal surface

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We illustrate that the surface plasmon polariton (SPP) excitation through the prism coupling method is fundamentally limited by destructive interference of spatial light components. We propose that the destructive interference can be canceled out by tailoring the relative phase for the different wave-vector components. As a numerical demonstration, we show that through the phase modulation the excited SPP field is concentrated to a hot energy spot, and the SPP field intensity is dramatically enhanced about three-fold in comparison with a conventional Gaussian beam illumination. The proposed phase-shaped beam approach provides a new degree of freedom to fundamentally control the SPP excitation and benefits the development of surface-enhanced applications. © 2014 Optical Society of America

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Recently, particular attention has been attracted by using the spatial control techniques to control the excitation and concentration of light in a variety of optical systems. Vellekoop *et al.* demonstrated that sending light through a random scattering medium, with a spatially modulated input wavefront, can achieve the constructive interference at a focus spot, resulting in focusing beyond the diffraction limit [1]. This effect can be interpreted as time-reversal of light emitted from a point emitter [2]. A similar idea has also been applied to generate and control the location of light hot spots in a diffraction grating [3] and to experimentally focus surface plasmon wave on a metal surface of a nanohole array [4]. In another related work, Kao *et al.* proposed that in a plasmonic metamaterial the strong optically induced interactions between discrete metamolecules can be manipulated to realize a subwavelength scale energy localization through spatially tailoring the phase profile of a continuous-wave input light beam [5]. Conceptually, these spatial control methods have the strong analogy to the coherent control methods where an incident optical pulse is modulated in the time domain to steer light-matter interaction [6–8] or the response of optical systems [9–12] toward a desired final state.

Since a flat metal surface is the simplest geometry sustaining surface plasmons, it is of fundamental importance in plasmonics to efficiently excite the surface plasmon polariton (SPP) field on the surface [13]. The established excitation techniques, including the prism coupling method, have practical significance for applications including surface-enhanced sensing and spectroscopy [14,15], plasmonic nonlinear optics [16–18], and plasmon optical tweezers [19–21]. Here we propose that the SPP excitation on a flat metal surface can be dramatically enhanced by phase modulation of each wave-vector

component of an incident light. We show that under a conventional illumination the spatial components of the incident light have destructive interference on the SPP excitation, and it strongly limits the SPP excitation and lowers the field intensity. We demonstrate that the destructive interference can be canceled out by shaping the illumination beam with a tailored relative phase for the different wave-vector components. As a consequence, the excited SPP field under the phase-shaped beam illumination is concentrated to a hot energy spot, and the electric field intensity is enhanced about three-fold at the peak in comparison with the conventional Gaussian beam illumination.

To clearly show the interference effect, we develop a spatial coupled-mode formula to model the SPP excitation process. To excite the SPP field at a metal-dielectric surface the prism coupling method of the Kretschmann and Otto configurations is commonly employed to satisfy the phase-matching requirement. Our theory can be generally applied to the prism coupling cases. As an example, here we consider a Kretschmann configuration [Fig. 1(a)], where a *p*-polarized incident beam illuminates a metal layer coating on a quartz prism. When the parallel component of the incident wave vector, k_z , is close to the SPP wave vector, the incident light excites SPP through the evanescent wave. Meanwhile the excited SPP leaks out and generates the radiation wave in quartz as it propagates along the *z* direction. Therefore, the reflection process consists of two pathways: the direct reflectance of the incident wave at the quartz-metal interface, and the outgoing radiation from the leakage of the excited SPP at the metal-air interface.

Based on the spatial coupled-mode theory (CMT) formalism [22], such an excitation process can be described by the following equations:

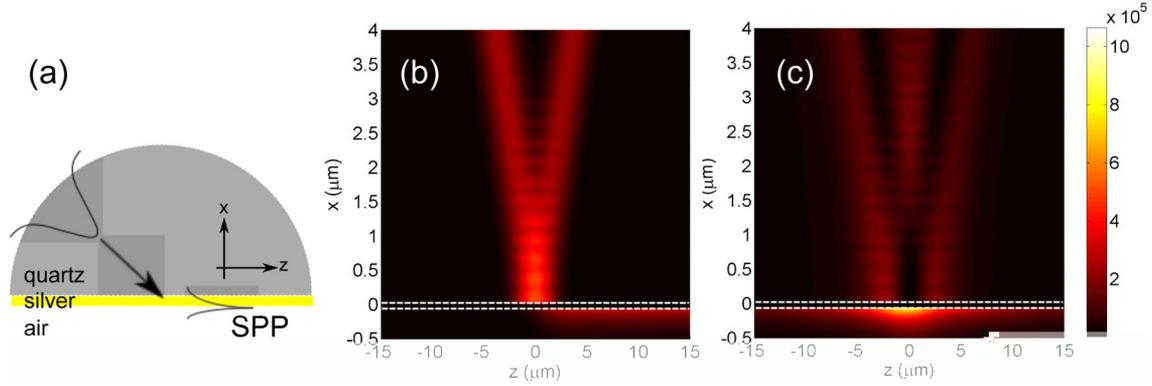


Fig. 1. (a) Schematic of a SPP excitation with the Kretschmann configuration. The thickness of the silver layer is 58.3 nm, and the dielectric constant of the quartz prism is $\epsilon_d = 2.25$. (b),(c) Distribution of the electric field intensity $|E|^2$ under the illumination of a Gaussian beam (b) and the phase-shaped beam (c). Here the white dashed lines outline the interfaces of the metal layer.

$$\frac{da}{dz} = (i\beta_{\text{spp}} - \alpha_l - \alpha_{\text{spp}})a + ie^{i\phi} \sqrt{2\alpha_l} S_{\text{in}}(z), \quad (1a)$$

$$S_{\text{out}} = e^{i\phi} S_{\text{in}} + ie^{i\phi} \sqrt{2\alpha_l} a. \quad (1b)$$

Here we take the convention that the field varies in time as $\exp(-i\omega t)$. a is the amplitude of the SPP, which is normalized such that $|a|^2$ corresponds to the time-averaged power along z direction. β_{spp} is the propagation constant of the SPP mode. $S_{\text{in}}(z)$ ($S_{\text{out}}(z)$) corresponds to the amplitude of the incident (reflective) light with the normalization of $|S_{\text{in}}|^2$ ($|S_{\text{out}}|^2$) giving the x -direction Poyntin flux. ϕ is the phase change of the reflection at the quartz-metal interface. α_l and α_{spp} correspond to the loss rate of the SPP due to the leaky radiation and that of the propagation loss due to intrinsic material absorption, respectively. Note that the spatial CMT takes the approximation of the strong confinement condition, i.e., $\alpha_l + \alpha_{\text{spp}} \ll \beta_{\text{spp}}$. We will see below in the numerical example that such an approximation is in fact sufficient for the SPP excitation at a real silver interface.

Let us consider two different scenarios with the spatial CMT theory. First, when the metal has an infinite thickness, the leaky rate $\alpha_l = 0$. In this case, Eqs. (1a) and (1b) are decoupled: the stable solution $a = \exp(i\beta_{\text{spp}}z - \alpha_{\text{spp}}z)$ of Eq. (1a) presents the SPP propagating in the z direction, and Eq. (1b) turns out as $S_{\text{out}} = e^{i\phi} S_{\text{in}}$, i.e., the reflected light solely experiences the phase change at the quartz-metal surface. In contrast, if the metal thickness is finite, Eq. (1a) shows the SPP excitation through the mode coupling. Equation (1b) indicates the reflective light contributed from the SPP excitation and the direct reflection at the quartz-metal surface. In this case, we expand the incident (reflected) beam into a series of plane waves as $S_{\text{in(out)}} = \int_{-\infty}^{\infty} s_{\text{in(out)}}(k_z) \exp(ik_z z) dk_z$. On substituting into Eq. (1), the amplitude of the excited SPP and the reflection coefficient are obtained:

$$a(z) = \sqrt{2\alpha_l} e^{i\phi} \int_{-\infty}^{\infty} \frac{s_{\text{in}}(k_z) \exp(ik_z z)}{(k_z - \beta_{\text{spp}}) - i(\alpha_l + \alpha_{\text{spp}})} dk_z, \quad (2a)$$

$$R \equiv \frac{S_{\text{out}}}{S_{\text{in}}} = e^{i\phi} \frac{(k_z - \beta_{\text{spp}}) + i\alpha_l - i\alpha_{\text{spp}}}{(k_z - \beta_{\text{spp}}) - i\alpha_l - i\alpha_{\text{spp}}}. \quad (2b)$$

Equation (2a) indicates that the amplitude of the excited SPP is sensitive to the phase of different incident wave-vector components $s_{\text{in}}(k_z)$. Particularly, the denominator of the integrand's denominator changes sign in its real part about β_{spp} . When the incident light is a conventional light beam such as a Gaussian beam, where $s_{\text{in}}(k_z)$ has linear phase variation about β_{spp} , the components with $k_z < \beta_{\text{spp}}$ and $k_z > \beta_{\text{spp}}$ have opposite contributions to the SPP excitation. As a result, a destructive interference arises, which strongly limits the peak intensity of the excited field. The analogous destructive interference also occurs in the time domain, where an excited state is subject to a conventional unchirped pulse in the applications of optically induced resonant transitions [7] and all-optical bistable switching [12]. Thus, in order to cancel out such destructive interference, a wave-vector-dependent phase modulation on s_{in} is required to balance the phase change around the SPP resonance:

$$\tilde{s}_{\text{in}} = s_{\text{in}}(k_z) \exp(i \arg[(k_z - \beta_{\text{spp}}) - i(\alpha_l + \alpha_{\text{spp}})]). \quad (3)$$

This phase modulation can be achieved experimentally through a 4f Fourier transformation system, where a transmissive spatial light modulator is positioned at the Fourier plane and modulates the phase for the different wave-vector components.

We numerically demonstrate this idea of enhancing the SPP excitation by a spatially modulated beam in a Kretschmann configuration [Fig. 1(a)], where the thickness of the silver layer is 58.3 nm, and the dielectric constant of the quartz prism is $\epsilon_d = 2.25$. For silver, we assume a Drude permittivity dispersion $\epsilon_m = \epsilon_\infty - \omega_p^2 / (\omega^2 + i\gamma_d \omega)$, $\epsilon_\infty = 4.039$, $\omega_p = 1.391 \times 10^{16}$ rad · Hz, $\gamma_d = 3.139 \times 10^{13}$ rad · Hz, based on experimentally retrieved silver dispersion at the room temperature [23].

To determine the parameters of the spatial CMT theory, we fit Eq. (2b) to the amplitude and phase spectra of the reflection coefficients obtained from numerical simulation. Assuming that the wavelength of the incident light in free-space is $\lambda_0 = 632$ nm, the solid lines in Fig. 2 correspond to the amplitude and phase spectra of R , which are calculated by the transfer matrix method [24]. From Eq. (2b) we see that the phase of R should have a 2π shift as k_z changes from $k_z \ll \beta_{\text{spp}}$ to $k_z \gg \beta_{\text{spp}}$ when $\alpha_l > \alpha_{\text{spp}}$. In the range of $k_z = 1 - 1.06k_0$ ($k_0 = 2\pi/\lambda_0$),

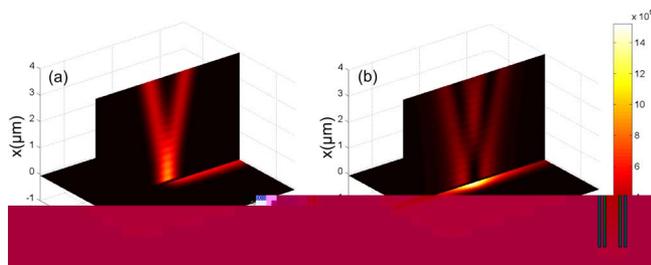


Fig. 4. Distribution of the electric field intensity $|E|^2$ under the illumination of (a) the 3D p -polarization Gaussian beam and (b) the phase-shaped beam with the phase modulation of Eq. (3). The Gaussian beam has a $2.652 \mu\text{m}$ radius waist and focuses at the quartz-metal surface.

sharp field intensity of SPP excitation leads to strong optical gradient forces. Moreover, the phase shaping provides a new degree of freedom to fundamentally control the SPP excitation to move or sort micro-objects, and the spatial CMT is vital to design the phase modulation for a demanded intensity profile.

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